



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 2221

Myounggoo LEE et al.

Group Art Unit: 1753

Application No.: 10/658,460

Examiner: R.G. McDonald

Filed: September 10, 2003

Attorney Docket No.: 029567-00004

For: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS SPUTTERING
FILM FORMING APPARATUS

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: July 2, 2007

Sir:

Applicant petitions for an extension of time for two months for response to the outstanding Office Action dated February 5, 2007 from May 5, 2007 to July 5, 2007.

Please find attached a check in the amount of \$450.00 to cover the fee discussed above. The Commissioner is hereby authorized to charge any fee deficiency or credit any overpayment associated with this communication to Deposit Account No. 01-2300, referencing our Docket Number 029567-00004.

Respectfully submitted,

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